PATENT Docket No.: 67161-115

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Customer Number: 20277 In re Application of

Confirmation Number: Shoji ISHIDA

Group Art Unit: Serial No.:

Examiner: Filed: October 10, 2003

SEMICONDUCTOR MANUFACTURING APPARATUS ENABLING INSPECTION OF For:

MASS FLOW CONTROLLER MAINTAINING CONNECTION THERETO

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of each of the six references listed on the attached Form 1449, is discussed in the present specification.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTTA WILL & EMERY

Stephen A. Becker

Registration No. 26,527

600 13th Street, N.W. Washington, DC 20005-3096 (202) 756-8000 SAB:gav Facsimile: (202) 756-8087

Date: October 10, 2003

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)					ATTY. DOCKET NO. 67161-115	SERIA [case	SERIAL NO. [case_serial_number]		
					APPLICANT Shoji ISHIDA				
					FILING DATE October 10, 2003	GRO [cas	UP e_gro	oup_art]	
				U.S. PATENT	DOCUMENTS			O Loren Lin	oc Where
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.